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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	Unknown - 10/730,641
Filing Date	Even Date Herewith - 12/8/03
First Named Inventor	Farrar, Paul
Group Art Unit	Unknown - 2815
Examiner Name	Owens, Beth - Fenty, Jesse

Sheet 1 of 5

Attorney Docket No: 1303.041US2

US PATENT DOCUMENTS

Examiner Initial*	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date if Appropriate
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STATEMENT BY APPLICANT**

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Complete if Known

Application Number	Unknown 10/730,641
Filing Date	Even Date Herewith 12/8/83
First Named Inventor	Farrar, Paul
Group Art Unit	Unknown 2815
Examiner Name	Owens, Beth Fenty, Jesse

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Attorney Docket No: 1303.041US2

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	Application Number	Unknown 10/730,641
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	First Named Inventor	Farrar, Paul
	Group Art Unit	Unknown 2815
	Examiner Name	Owens, Beth Fenty, Jesse
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Group Art Unit	Unknown 2815
Examiner Name	Owens, Beth FENTY, JESSE

Sheet, 4 of 5

Attorney Docket No: 1303.041US2

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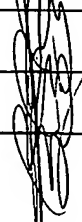
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First Named Inventor	Farrar, Paul
Group Art Unit	Unknown 2815
Examiner Name	Owens, Beth Fenty, Jesse

Sheet 5 of 5

Attorney Docket No: 1303.041US2

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